
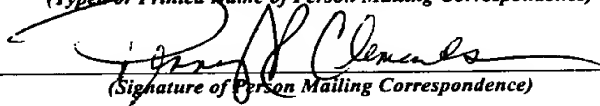


2811

<b>CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)</b>			Docket No. 90065.99R272/17732.6323	
Applicant(s): Jifa Hao, et al.				
Serial No. 09/654,845	Filing Date September 1, 2000	Examiner Ori Nadav	Group Art Unit 2811	
Invention: POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCE CAPABILITY AND PROCESS FOR FORMING SAME				
				
I hereby certify that this <u>Response to Restriction Requirement</u> <i>(Identify type of correspondence)</i>				
is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on <u>January 4, 2002</u> <i>(Date)</i>				
<u>Penny P. Clements</u> <i>(Typed or Printed Name of Person Mailing Correspondence)</i>				
 <i>(Signature of Person Mailing Correspondence)</i>				
Note: Each paper must have its own certificate of mailing.				
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